

DOCKET NO: 283485US0PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

:

MASATOMO SUMIYA, ET AL.

: EXAMINER: LEONG, NATHAN T.

SERIAL NO: 10/562,265

:

FILED: MAY 24, 2006

: GROUP ART UNIT: 1792

FOR: METHOD FOR GROWING THIN
NITRIDE FILM ONTO SUBSTRATE AND
THIN NITRIDE FILM DEVICE

:

AMENDMENT AND REQUEST FOR CONTINUED
EXAMINATION (RCE) UNDER 37 C.F.R. § 1.114

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Official Action dated July 27, 2009, reconsideration is respectfully requested in the above-identified application in view of the following amendments and remarks submitted in conjunction with a Request for Continued Examination (RCE):

Amendments to the Claims begin on page 2 of this response.

Support for the Amendments begin on page 4 of this response.

Remarks begin on page 5 of this response.